



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Terunao HANAOKA et al.

Group Art Unit: 2814

Application No.: 10/767,999

Examiner: P. CAO

Filed: February 2, 2004

Docket No.: 109690.02

For: SEMICONDUCTOR DEVICE, METHOD OF FABRICATING THE SAME, STACK-  
TYPE SEMICONDUCTOR DEVICE, CIRCUIT BOARD AND ELECTRONIC  
INSTRUMENT

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- ☒ 2. Each item of information contained in this Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart application, and this communication was not received by any individual designated in §1.56(c) more than thirty days prior to the filing of this Information Disclosure Statement.
- ☒ 3. The references were cited in a corresponding Japanese Office Action.

- ☒ 4. The references were cited by or submitted to the Office in parent application No. 10/768,168, filed February 2, 2004, which is relied upon for an earlier filing date under 35 U.S.C. §120. Thus, copies of these references are not attached. 37 CFR §1.98(d).

Respectfully submitted,



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Date: September 12, 2005

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<p>DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461</p>
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Sheet 1 of 1Form PTO-1449  
(REV. 8-83)Dept. of Commerce  
PATENT & TRADEMARK OFFICEATTY DOCKET NO.  
109690.01APPLICATION NO.  
10/767,999

## INFORMATION DISCLOSURE STATEMENT

(Use several sheets if necessary)

APPLICANT(S)  
Terunao HANAOKA et al.FILING DATE  
February 2, 2004GROUP  
2814

## U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS

## FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS
	1	JP-A-06-310547 (w/English-language Abstract & Translation)	11/04/1994	JAPAN		
	2	JP-A-09-246318 (w/English-language Abstract & Translation)	09/19/1997	JAPAN		
	3	JP-A-05-029537 (w/English-language Abstract & Translation)	02/05/1993	JAPAN		
	4	JP-A-05-251455 (w/English-language Abstract & Translation)	09/28/1993	JAPAN		
	5	JP-A-08-124930 (w/English-language Abstract & Translation)	05/17/1996	JAPAN		
	6	JP-A-08-330313 (w/English-language Abstract & Translation)	12/13/1996	JAPAN		
	7	JP-A-03-253025 (w/English-language Abstract)	11/12/1991	JAPAN		
	8	JP-63-126250 (w/English-language Abstract)	05/30/1988	JAPAN		

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)


EXAMINER

DATE CONSIDERED

Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Date: September 12, 2005